

<b>Notice of References Cited</b>	Application/Control No. 10/625,630	Applicant(s)/Patent Under Reexamination TAMURA ET AL.	
	Examiner Andy Huynh	Art Unit 2818	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,914,785	10-1975	Ketchow, Doris Rahb	257/96
	B	US-3,923,875	12-1975	Rose et al.	560/244
	C	US-4,188,710	02-1980	Davey et al.	438/508
	D	US-4,471,366	09-1984	Delagebeaudeuf et al.	257/194
	E	US-4,593,301	06-1986	Inata et al.	257/194
	F	US-4,673,959	06-1987	Shiraki et al.	257/20
	G	US-5,060,031	10-1991	Abrokwhah et al.	257/274
	H	US-5,144,410	09-1992	Johnson, David A.	257/745
	I	US-5,381,027	01-1995	Usagawa et al.	257/192
	J	US-5,480,829	01-1996	Abrokwhah et al.	438/169
	K	US-5,907,164	05-1999	Nakayama, Tatsuo	257/192
	L	US-6,194,747	02-2001	Onda, Kazuhiko	257/192
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.